

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Patent Application of

Hans-Stephan Albrecht, et al

Application No.: 09/903,425

Filed: July 10, 2001

For: PRECISE MONITOR ETALON  
CALIBRATION TECHNIQUE

Confirmation No.: 8935

Group Art Unit: 2828

Examiner: Hung T. Vy

**COMMENTS ON STATEMENT OF  
REASONS FOR ALLOWANCE**

353 Sacramento Street, Suite 2200  
 San Francisco, CA 94111  
 Telephone: (415) 772-4900  
 Facsimile: (415) 398-2890

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope, addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on July 2, 2004.

STALLMAN &amp; POLLOCK LLP

Dated: 07/2 /2004 By: Georgia K. Stith  
 Georgia K. Stith

M/S ISSUE FEE  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Sir:

In response to the Notice of Allowability for above-referenced matter, Applicants note with appreciation the indication that claims 1-19 are allowed.

It is further noted that the Notice of Allowability includes a statement of "Reasons for Allowance". The Reasons for Allowance includes certain language which is not included in all of the allowed claims. For example, the Reasons for Allowance refers to "adjusting the wavelength of the laser beam to the target wavelength when the compensated wavelength differs from the target wavelength". It is respectfully submitted that not all of the allowed independent claims recite this operation. Thus, it is respectfully submitted that each of the individual claims should be interpreted according to the specific language recited in each of the respective claims,

and that all the elements recited in the Examiner's Reasons for Allowance should not be read into all the allowed claims.

Respectfully submitted,

STALLMAN & POLLOCK LLP

Dated: July 2, 2004

By:



Brian J. Keating  
Reg. No. 39,520

Attorneys for Applicant(s)